

Special Issue

Piezoelectric Materials, Devices and Integrated Systems

Message from the Guest Editors

All interested researchers are invited to contribute to this Special Issue with their original research articles, communications and review articles. Manuscripts will be internationally peer-reviewed. Please note that all submitted papers must be within the general scope of the Micromachines journal. Topics may include, but are not limited to, the following:

- Novel methods for the preparation of piezoelectric materials;
- Novel modelling and design methods of piezoelectric devices;
- Integrated circuit design for piezoelectric applications;
- Simulation and design methods of 3D-integrated systems;
- Promising applications of piezoelectric materials, devices, and integrated systems.

Guest Editors

Dr. Dongdong Chen

Dr. Di Li

Dr. Tianlong Zhao

Dr. Yi Quan

Deadline for manuscript submissions

closed (30 January 2024)



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Micromachines
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
micromachines@mdpi.com

[mdpi.com/journal/
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About the Journal

Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China

2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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